



image

2814.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of)
)
Kazuo MAEDA) Examiner: Quach
)
Serial No.: 09/519,599 ✓) Art Unit: 2814
)
Filed: March 6, 2000)
)
For: METHOD AND APPARATUS FOR)
FORMING AN INTERLAYER)
INSULATING FILM AND)
SEMICONDUCTOR DEVICE)

SUPPLEMENTAL RESPONSE TO OFFICE ACTION OF APRIL 23, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Supplemental to applicants' response filed August 14, 2003, please amend the captioned application as follows: